



# UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/956,986	09/21/2001	Michiharu Matsui	214258US2S	2952
22850	7590	12/09/2003	EXAMINER	
OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314			TRAN, THIEN F	
			ART UNIT	PAPER NUMBER
			2811	

DATE MAILED: 12/09/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

<p align="center"><b>Office Action Summary</b></p>	<p>Application No.</p> <p>09/956,986</p>	<p>Applicant(s)</p> <p>MATSUI ET AL.</p>	
	<p>Examiner</p> <p>Thien F Tran</p>	<p>Art Unit</p> <p>2811</p>	

**-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --**

**Period for Reply**

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).
- Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

**Status**

- 1) ☐ Responsive to communication(s) filed on \_\_\_\_.
- 2a) ☐ This action is **FINAL**.                      2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

**Disposition of Claims**

- 4) ☒ Claim(s) 1-60 and 62 is/are pending in the application.
- 4a) Of the above claim(s) 2,4,6,8-10,12,13,15-31,33,35 and 37-60 is/are withdrawn from consideration.
- 5) ☐ Claim(s) \_\_\_\_ is/are allowed.
- 6) ☒ Claim(s) 1,3,5,7,11,14,32,34,36 and 62 is/are rejected.
- 7) ☐ Claim(s) \_\_\_\_ is/are objected to.
- 8) ☐ Claim(s) \_\_\_\_ are subject to restriction and/or election requirement.

**Application Papers**

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on \_\_\_\_ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.  
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

**Priority under 35 U.S.C. §§ 119 and 120**

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  
a) ☐ All   b) ☐ Some \* c) ☐ None of:  
1. ☐ Certified copies of the priority documents have been received.  
2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_.  
3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  
\* See the attached detailed Office action for a list of the certified copies not received.
- 13) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.  
a) ☐ The translation of the foreign language provisional application has been received.
- 14) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.

**Attachment(s)**

- |   |   |
|---|---|
| 1) <input type="checkbox"/> Notice of References Cited (PTO-892)  | 4) <input type="checkbox"/> Interview Summary (PTO-413) Paper No(s). ____   |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)                                | 5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO-1449) Paper No(s) <u>10/31/2003</u> | 6) <input type="checkbox"/> Other:  |

## **DETAILED ACTION**

### ***Specification***

The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed, a device.

The following title is suggested: Nonvolatile semiconductor memory device having element isolating region of trench type.

### ***Claim Rejections - 35 USC § 102***

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1, 3, 5, 7, 32, 34, 36 and 62 are rejected under 35 U.S.C. 102(e) as being anticipated by Shimizu et al. (USPN 6,342,715).

Shimizu et al. discloses the claimed semiconductor device (Figs. 60, 61A, 61B, 62A) comprising a semiconductor layer 1; a first insulating film 54 formed on said semiconductor layer; a first electrode layer 55 formed on said first insulating film; a plurality of element isolating regions 2 comprising an element isolating insulating film formed to extend through said first electrode layer and said first insulating film to reach an inner region of said semiconductor layer, said element isolating regions isolating an element region and being self-aligned with said first electrode layer; a second insulating

Art Unit: 2811

film 6 formed on said first electrode layer across said element isolating regions, an open portion exposing a surface of said first electrode layer being formed in said second insulating film; and a second electrode layer 57 formed on said second insulating film and said exposed surface of said first electrode layer, said second electrode layer being electrically connected to said first electrode layer via said open portion, said first and second electrode layers including a gate electrode, said open portion having a first width in a direction of a gate length of said gate electrode and a second width in a direction perpendicular to the direction of the gate length, the second width being greater than the first width, the open portion extending in a direction of the second width across the element isolating regions (attached Figs. 61A-61B and 62A show an open portion marked with red extending in a direction of a second width across the two element isolating regions 2).

Regarding claim 3, said gate electrode is a gate electrode 58 of a selective transistor included in a NAND type flash memory.

Regarding claim 5, Shimizu et al. further discloses a semiconductor device (Fig. 62B) in a memory cell array region comprising said semiconductor layer 1; said first insulating film 42 formed on said semiconductor layer; said first electrode layer 5 formed on said first insulating film; said element isolating regions 2 comprising an element isolating insulating film formed to extend through said first electrode layer and said first insulating film to reach an inner region of said semiconductor layer, said element isolating regions isolating an element region and being self-aligned with said first electrode layer; said second insulating film 6 formed on said first electrode layer and

Art Unit: 2811

said element isolating regions; and said second electrode layer 7 formed on said second insulating film; wherein a surface of said element isolating regions of said memory cell array region is arranged below a surface of said first electrode layer.

Regarding claim 7, said first electrode layer 5 performs a function of a floating gate and said second electrode layer 7 performs a function of a control gate in said memory cell array region.

Regarding claim 32, the first electrode layer 55 formed of polysilicon film 13 and the second electrode layer 57 formed of metal silicide film 19, which achieves lower resistance.

Regarding claim 34, said second insulating film 6 comprises of a complex insulating film including a silicon nitride film.

Regarding claim 36, said second insulating film 6 remains at an edge portion of said gate electrode.

Regarding claim 62, a groove is formed in said element isolating insulating film 2 (Fig. 61A), said groove is located under said open portion, and has a same shape as said open portion.

### ***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

Claims 11 and 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shimizu et al. (USPN 6,342,715) in view of Admitted prior art (APA).

Shimizu et al. as described above does not disclose a connecting member arranged above one of said element isolating regions 2 and a wiring electrically connected to said second electrode layer 57 via said connecting member so that a voltage can be applied to the gate electrode. It is old and well known to form an interconnect comprising a wiring and a connecting member arranged above an element isolation region as shown for example by APA (Fig. 49B). APA discloses a connecting member 20 arranged above an element isolating region 15 and electrically connected to a second electrode layer 18, and a wiring 21 electrically connected to said second electrode layer 18 via the connecting member 20, wherein said wiring and a first electrode layer 13 are connected to each other via said second electrode layer 18 extending from said element region onto said element isolating region. It would have been obvious to a person having ordinary skill in the art to form a wiring and a connecting member as taught by APA above the element isolating region 2 of Shimizu et al. so that the first electrode layer 55 can be electrically connected to an external source (voltage) through the second electrode layer 57, the connecting member and the wiring in order for the selective transistor to be operated.

### ***Response to Arguments***

Applicant's arguments filed 09/10/2003 have been fully considered but they are not persuasive. Applicant argues that Shimizu et al. discloses an open portion formed in the shape of an island for every element region. Based only on Fig. 60 of Shimizu,

Art Unit: 2811

applicant concludes the open portion does not extend in a direction perpendicular to the direction of a gate length across a plurality of element isolating regions. The examiner respectfully disagrees with the remark because Fig. 60 by itself does not provide sufficient information. It is the combination of the drawings of Shimizu as mentioned above that clearly show an open portion extending in a direction perpendicular to the direction of a gate length across a plurality of element isolating regions.

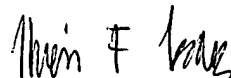
### **Conclusion**

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thien F Tran whose telephone number is (703) 308-4108. The examiner can normally be reached on 8:30AM - 5:00PM Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie C Lee can be reached on (703) 308-1690. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9318.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

tt  
December 2, 2003



Thien F Tran  
Primary Examiner